



Form <del>PTO</del> 1449 (Modified) 2004 <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>  (Use several sheets if necessary)	Atty Docket No. AF01194	Serial No. 10/731,494
	Applicant: Halliyal et al.	
	Filing Date 12/09/03	Group 2812

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	5,284,549	02/08/94	Barnes et al.	156	662	
	5,648,113	07/15/97	Barbee et al.	427	8	
	5,707,901	01/13/98	Cho et al.	438	595	
	5,840,600	11/24/98	Yamazaki et al.	438	51	
	5,872,387	02/16/99	Lyding et al.	257	607	
	5,970,384	10/19/99	Yamazaki et al.	438	795	
	6,022,799	02/08/00	Foote et al.	438	637	
	6,037,003	03/14/00	Gordon et al.	427	255.34	
	6,180,190 B1	01/30/01	Gordon	427	565	
	6,190,966 B1	02/20/01	Ngo et al.	438	257	
	6,194,784 B1	02/27/01	Parat et al.	257	774	
	6,306,777 B1	10/23/01	Ogle, Jr. et al.	438	763	
	6,319,809 B1	11/20/01	Chang et al.	438	597	
	6,319,775 B1	11/20/01	Halliyal et al.	438	261	
	6,468,599 B1	10/22/02	Terada	427	558	
	6,479,379 B2	11/12/02	Reinberg	438	635	
	2002/0068229 A1	06/06/02	Westerman et al.	430	5	

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Sub-class	Translation	
						Yes	No

## OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
	U.S. Patent Application Serial No. 10/731,659 filed December 9, 2003, entitled "PROCESS FOR FABRICATION OF NITRIDE LAYER WITH REDUCED HYDROGEN CONTENT IN ONO STRUCTURE IN SEMICONDUCTOR DEVICE."

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.

EXAMINER <i>W. Keith D. McL</i>	DATE CONSIDERED <i>January 28, 2005</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

### Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

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